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PATENT
8020-1021-1

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of:

Yoshihisa MATSUBARA

Confirmation No. 7618

Serial No. 10/624,596

GROUP 2814

Filed July 23, 2003

Examiner Ginette Peralta

SEMICONDUCTOR DEVICE AND MANUFACTURING
METHOD OF THE SAME

SUPPLEMENTAL AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 7, 2004

Sir:

In response to the Official Action of June 17, 2004,
and supplemental to the amendment filed September 17, 2004,
reconsideration and withdrawal of the rejections are solicited
for the additional reasons provided herein.

Remarks begin on page 2 of this paper.